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COF
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:)	
Chidane OUCHI)	Examiner: M. A. Lyons
Application No.: 10/693,880)	Group Art Unit: 2877
Filed: October 28, 2003)	
For: INTERFERENCE SYSTEM AND)	January 26, 2006
SEMICONDUCTOR EXPOSURE APPARATUS)	
HAVING THE SAME)	
U.S. Patent No. 6,961,132 B2)	Certificate
Issued: November 1, 2005)	FEB 14 2006
)	of Correction

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Attention: Certificate of Correction Branch

LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

Patentee notes the following errors in the above-identified patent:

COLUMN 1:

Line 23, "is" should read -- in --.

COLUMN 4:

Line 62, "heigh" should read -- height --.

Line 65, "hte" should read -- the --.

These errors are relatively insignificant. Therefore, Patentee believes that filing a Request for Certificate of Correction is not warranted. Rather, Patentee requests that this paper be placed of record in the official file of the subject patent.

Patentee believes no fee is due for filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed required.

Patentee's undersigned attorney may be reached in our Washington, D.C. Office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Steven E. Warner", written over a horizontal line.

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